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**MAR 30 2007**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

APPLICANT: Keshner, M.

DOCKET NO: 200308866-1

SERIAL NO.: 10/618,478

EXAMINER: Bret P. Chen

FILED: July 11, 2003

ART UNIT: 1762

**TITLE: ROLL-VORTEX PLASMA CHEMICAL VAPOR DEPOSITION SYSTEM**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

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March 30, 2007

I hereby certify that on the 30<sup>th</sup> day of March, 2007, this correspondence is being sent via facsimile to Examiner Bret P. Chen in Art Group 1762 at (571) 273-8300.

  
Jeffrey Weiss

**AMENDMENT**

Dear Sir:

This Amendment is in response to the January 11, 2007 Final Office Action concerning the above-identified application. Amendments to the Claims begin on page 2, and the Remarks begin on page 8 of the Amendment.

Please amend the subject patent application as follows:

*OK to enter  
bc  
5/2007*